

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/786,799	CHEN ET AL.	
Examiner	Art Unit	
Y. J. Han	2838	

	SEAR	CHED	
Class	Subclass	Date	Examiner
323	313		
	314		
	316		
	274-281		
327	539		
	540		
323	317	3/17/2006	JH

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
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